

**Abstract****Method For Producing A Ceramic Substrate**

5        The invention relates to a method for the production of a ceramic substrate, wherein the steps of debinding and sintering are performed in direct succession without the multi-layer substrate being cooled in between. This achieves the advantage of reducing the risk of crack development. In an advantageous variant of the invention, a part of the debinding is performed in an inert atmosphere, the atmosphere subsequently being converted to air. In this process, the temperature is simultaneously reduced to a value which, however, does not fall below the minimum temperature of the debinding, in order to prevent excessively rapid oxidation of organic components of the binders and the explosion-like discharge of CO<sub>2</sub>.

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15        Figure 1